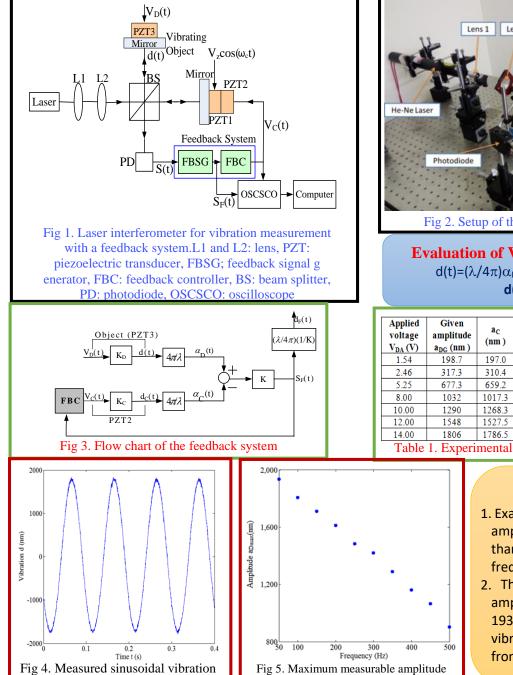
## A FEEDBACK CONTROL SYSTEM WITH A LASER INTERFEROMETER FOR EXACT AND REAL-TIME VIBRATION MEASUREMENT

Myint Thein<sup>1</sup>, Osami Sasaki<sup>2</sup>, Myo Maung Maung<sup>3</sup>, Naing Aung Soe<sup>3</sup>, Htay Htay Win<sup>3</sup> <sup>1,3</sup>Department of Mechanical Engineering, Mandalay Technological University, MTU, Myanmar <sup>2</sup>Niigata University, Faculty of Engineering, Niigata 950-2181, Japan <sup>3</sup>Department of Electrical Engineering, Mandalay Technological University, MTU, Myanmar

This research focus on exact and real-time vibration measurement using a PI (Proportional Integral) feedback control system in a Michelson interferometer with a Helium-Neon (He-Ne) Laser light source. The interferometer can measure a vibration of the object in real time by giving the reference PZT a voltage which is generated by the feedback control system using a signal processing circuit system. The sinusoidal phase-modulation frequency is 10 kHz. A multiplier and a low-pass filter (LPF) with a cut off frequency of 400 Hz function to extract a fundamental frequency component of the interference signal. The measured vibration waveform is calculated as the sum of two measured waveforms obtained from the controller output signal and the feedback signal in the feedback system, respectively.



| Lens 1 Lens 2                           |
|---|
| PZT3<br>PZT1                            |
| He-Ne Laser B5                          |
| Photodiode                              |
| M2                                      |
| Fig 2 Setup of the Laser Interferometer |

Fig 2. Setup of the Laser Interferometer

## Evaluation of Vibration Amplitude: $d(t)=(\lambda/4\pi)\alpha_{D}(t)=(\lambda/4\pi)[\alpha_{C}(t)+S_{F}(t)/K]$ $d(t) = d_{C}(t)+d_{F}(t)$

| Applied<br>voltage<br>V <sub>DA</sub> (V)         | Given<br>amplitude<br>a <sub>DG</sub> (nm ) | a <sub>C</sub><br>(nm) | a <sub>F</sub><br>(nm ) | Measured<br>amplitude<br>a <sub>D</sub> (nm ) | a <sub>DG</sub> - a <sub>C</sub><br>(nm ) | a <sub>DC</sub> - a <sub>D</sub><br>(nm) |  |
|---|---|------------------------|-------------------------|---|---|--|--|
| 1.54  | 198.7                                       | 197.0                  | 3.0                     | 200.0   | 1.7                                       | -1.3                                     |  |
| 2.46  | 317.3                                       | 310.4                  | 3.8                     | 314.2   | 6.9                                       | 3.1                                      |  |
| 5.25  | 677.3                                       | 659.2                  | 10.6                    | 669.8   | 18.1                                      | 7.5                                      |  |
| 8.00  | 1032  | 1017.3                 | 13.2                    | 1030.5  | 14.7                                      | 1.5                                      |  |
| 10.00   | 1290  | 1268.3                 | 15.7                    | 1284.0  | 21.7                                      | 6.0                                      |  |
| 12.00   | 1548  | 1527.5                 | 18.0                    | 1545.5  | 20.5                                      | 2.5                                      |  |
| 14.00   | 1806  | 1786.5                 | 21.7                    | 1808.2  | 19.5                                      | -2.2                                     |  |
| Table 1, Experimental Result at Different Voltage |   |                        |                         |   |   |  |  |

## **Conclusion:**

- 1. Exact measured vibration amplitude with error less than about 8 nm at vibration frequency of 100 Hz.
- 2. The maximum measurable amplitude decreases from 1935 nm to 903 nm when the vibration frequency increases from 50 Hz to 500 Hz.